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April 1st, 2010
Renesas Electronics Corporation

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1. Electrical Characteristics Definition and Usage Explanation

1.1 Absolute Maximum Ratings and Electrical Characteristics

1.1.1 Absolute Maximum Ratings

Figure 1.1 shows the meaning of power MOSFET absolute maximum ratings.

<table>
<thead>
<tr>
<th>Item</th>
<th>Symbol</th>
<th>Rating</th>
<th>Unit</th>
</tr>
</thead>
<tbody>
<tr>
<td>Drain to source voltage</td>
<td>V_DSS</td>
<td>60</td>
<td>V</td>
</tr>
<tr>
<td>Gate to source voltage</td>
<td>V_GSS</td>
<td>±20</td>
<td>V</td>
</tr>
<tr>
<td>Drain current</td>
<td>I_D</td>
<td>85</td>
<td>A</td>
</tr>
<tr>
<td>Drain peak current</td>
<td>I_D(pulse) (\times 1)</td>
<td>340</td>
<td>A</td>
</tr>
<tr>
<td>Body-drain diode reverse drain current</td>
<td>I_DR</td>
<td>85</td>
<td>A</td>
</tr>
<tr>
<td>Avalanche current</td>
<td>I_AP (\times 2)</td>
<td>60</td>
<td>A</td>
</tr>
<tr>
<td>Avalanche energy</td>
<td>E_AR (\times 2)</td>
<td>308</td>
<td>mJ</td>
</tr>
<tr>
<td>Channel dissipation</td>
<td>Pch (\times 3)</td>
<td>110</td>
<td>W</td>
</tr>
<tr>
<td>Channel temperature</td>
<td>T_ch</td>
<td>150</td>
<td>°C</td>
</tr>
<tr>
<td>Thermal resistance</td>
<td>θ_ch-c</td>
<td>1.14</td>
<td>°C/W</td>
</tr>
</tbody>
</table>

Notes: 1. Allowable value at PW ≤ 10 µs, duty ≤ 1%
2. Allowable value at Tch = 25°C, Rg ≥ 50Ω
3. Allowable value at Tc = 25°C

Figure 1 Power MOS FET Absolute Maximum Ratings
## 1.1.2 Electrical Characteristics

Table 1.1 shows the meaning of power MOSFET electrical characteristics.

### Table 1.1 Power MOS FET Electrical Characteristics

(\(Ta = 25{\degree}C\))

<table>
<thead>
<tr>
<th>Item</th>
<th>Symbols</th>
<th>Ratings</th>
<th>Test Conditions</th>
<th>Unit</th>
<th>Temperature Dependence</th>
<th>Design Notes</th>
</tr>
</thead>
<tbody>
<tr>
<td>Drain to source breakdown voltage</td>
<td>(V_{BR(DSS)})</td>
<td>60 — —</td>
<td>(I_D = 10mA, V_{GS} = 0)</td>
<td>V</td>
<td>●</td>
<td>Correlation to on-resistance</td>
</tr>
<tr>
<td>Zero gate voltage drain current</td>
<td>(I_{GS} )</td>
<td>— — 10</td>
<td>(V_{DS} = 60V, V_{GS} = 0)</td>
<td>(\mu A)</td>
<td>●</td>
<td>Thermal dependence is high, but low in terms of loss</td>
</tr>
<tr>
<td>Gate to source leakage current</td>
<td>(I_{GS} )</td>
<td>— — ±0.1</td>
<td>(V_{GS} = \pm 20V, V_{DS} = 0)</td>
<td>(\mu A)</td>
<td>—</td>
<td>For products with on-chip protective diode, several tens of nA to several (\mu A), guaranteed value of ±10 (\mu A)</td>
</tr>
<tr>
<td>Gate to source cutoff voltage</td>
<td>(V_{GS(off)})</td>
<td>1.0 — 2.5</td>
<td>(V_{DS} = 10V, I_D = 1mA)</td>
<td>V</td>
<td>○</td>
<td>Affects switching operation noise and switching time (tr, tf)</td>
</tr>
<tr>
<td>Forward transfer admittance</td>
<td>(</td>
<td>Y_{fs}</td>
<td>)</td>
<td>55 90</td>
<td>(I_D = 45A, V_{DS} = 10V)</td>
<td>(s)</td>
</tr>
<tr>
<td>Static drain to source on state resistance 1</td>
<td>(R_{D(on)})</td>
<td>— 4.3 5.5</td>
<td>(I_D = 45A, V_{DS} = 10V)</td>
<td>(m\Omega)</td>
<td>●</td>
<td>Most important parameters in determining on-loss. Note that these rise together with temperature.</td>
</tr>
<tr>
<td>Static drain to source on state resistance 2</td>
<td>(R_{D(off)})</td>
<td>— 6.0 9.0</td>
<td>(I_D = 45A, V_{GS} = 4V)</td>
<td>(m\Omega)</td>
<td>●</td>
<td></td>
</tr>
<tr>
<td>Input capacitance</td>
<td>(C_{iss})</td>
<td>— 9770</td>
<td>(V_{DS} = 10V, V_{GS} = 0, f = 1MHz)</td>
<td>(p\Omega)</td>
<td>—</td>
<td>(V_{DS}) dependent. Drive loss indicator in analog operation</td>
</tr>
<tr>
<td>Output capacitance</td>
<td>(C_{oss})</td>
<td>— 1340</td>
<td></td>
<td>(p\Omega)</td>
<td>—</td>
<td>(V_{DS}) dependent. Affects fall time (tf) under light load.</td>
</tr>
<tr>
<td>Reverse transfer capacitance</td>
<td>(C_{rss})</td>
<td>— 470</td>
<td></td>
<td>(p\Omega)</td>
<td>—</td>
<td>(V_{DS}) dependent. Influences switching time (tr, tf).</td>
</tr>
<tr>
<td>Total gate charge</td>
<td>(Q_g)</td>
<td>— 180</td>
<td>(V_{DD} = 50V, V_{GS} = 10V, I_D = 85A)</td>
<td>(nC)</td>
<td>—</td>
<td>Characteristic that determines drive loss. Greatly dependent on gate drive voltage.</td>
</tr>
<tr>
<td>Gate to source charge</td>
<td>(Q_{gs})</td>
<td>— 32</td>
<td></td>
<td>(nC)</td>
<td>—</td>
<td></td>
</tr>
<tr>
<td>Gate to drain charge</td>
<td>(Q_{gd})</td>
<td>— 36</td>
<td></td>
<td>(nC)</td>
<td>—</td>
<td>Characteristic that determines switching time (tr, tf). Dependent on power supply voltage (V_{DD}) (increases when (V_{DS}) rises).</td>
</tr>
<tr>
<td>Turn-on delay time</td>
<td>(t_{d(on)})</td>
<td>— 53</td>
<td>(V_{GS} = 10V, I_D = 45A, R_L = 0.67\Omega, R_{g} = 50\Omega)</td>
<td>ns</td>
<td>—</td>
<td>Determined by (R_{g}, Q_{gd}), and gate drive voltage. Influence diode on-loss in inverter use.</td>
</tr>
<tr>
<td>Rise time</td>
<td>(t_{r})</td>
<td>— 320</td>
<td>(I_D = 45A, R_{L} = 0.67\Omega, R_{g} = 50\Omega)</td>
<td>ns</td>
<td>—</td>
<td></td>
</tr>
<tr>
<td>Turn-off delay time</td>
<td>(t_{d(off)})</td>
<td>— 700</td>
<td></td>
<td>ns</td>
<td>—</td>
<td>Determined by (R_{g}, Q_{gd}), and (V_{th}). Influence surge voltage (noise) when switching off.</td>
</tr>
<tr>
<td>Fall time</td>
<td>(t_{f})</td>
<td>— 380</td>
<td></td>
<td>ns</td>
<td>—</td>
<td></td>
</tr>
<tr>
<td>Body-drain diode forward voltage</td>
<td>(V_{DF})</td>
<td>— 1.0</td>
<td>(I_{F} = 85A, V_{GS} = 0)</td>
<td>V</td>
<td>○</td>
<td>Becomes same characteristic as on-resistance when positive bias is applied to (V_{GS}).</td>
</tr>
<tr>
<td>Body-drain diode reverse recovery time</td>
<td>(t_{rr})</td>
<td>— 70</td>
<td>(I_{F} = 85A, V_{GS} = 0, di/dt = 50\mu A/\mu s)</td>
<td>ns</td>
<td>●</td>
<td>Short-circuit current: lowers di/dt to suppress noise.</td>
</tr>
</tbody>
</table>

Note: ●: Has positive temperature coefficient, ○: Has negative temperature coefficient
### 1.2 Relationship between On-Resistance $R_{DS(on)}$ and Withstand Voltage $V_{DSS}$

Figure 1.2 shows the relationship between a withstand voltage $V_{DSS} = 20$ to $100$ V rated component and on-resistance $R_{DS(on)}$. When selecting the withstand voltage of an component, a margin should be left in the settings with respect to circuit operation conditions power supply voltage $V_{DD}$ and surge voltage $V_{DS(peak)}$ generated when switching off. As $V_{DSS}$ has a positive temperature characteristic with respect to temperature, the minimum temperature environment conditions for use of the component must be taken into consideration.

![Figure 1.2 $R_{DS(on)} - V_{DSS}$ Relationship](image)

**Figure 1.2** $R_{DS(on)} - V_{DSS}$ Relationship

Figure 1.3 shows the $V_{BRDSS}$ temperature characteristic (taking the example of the 2SK3418). In this case, making the withstand voltage margin larger than necessary is inadvisable as it will result in higher on-resistance and greater steady-state loss. Recently, components have appeared that can handle guaranteed avalanche resistance in order to reduce this margin as much as possible and provide the benefit of lower loss.

![Figure 1.3 $V_{BRDSS} - Tc$ Characteristics (2SK3418)](image)

**Figure 1.3** $V_{BRDSS} - Tc$ Characteristics (2SK3418)
1.3 Saturation Voltage $V_{DS(on)} (= I_d \times R_{DS(on)})$ Gate Drive Voltage Dependence

This characteristic is a characteristic curve for designing at what gate drive voltage the $V_{DS(on)}$ area (on-resistance area) is effected in the case of a predetermined operating current $I_d$.

In the case of power MOS FETs, 10 V drive components, 4 V drive components, 4 V drive (or lower) components are produced according to the gate drive operating current. The means of achieving low-voltage drive is generally to use a thin gate oxide film (whereby the gate-source withstand voltage $V_{GS}$ rating is reduced) to attain a lower $V_{GS(off)}$ value. $V_{GS(off)}$ has an approximately $–5 \text{ mV/°C}$ negative temperature coefficient (characteristic that falls approximately 0.5 V with a 100°C rise).

When selecting the type of component in terms of drive voltage, it is necessary to consider the application (for example, selection of a 10 V drive component with a high $V_{GS(off)}$ value to cope with noise in switching power supply or motor drive applications) and the specifications of the gate drive IC or LSI to be used (such as a low-level voltage that keeps the MOS FET off).

Recently, therefore, a distinction may be made between the use of 4 V drive components and 10 V drive components according to the conditions of use and application even in automotive electrical equipment.
1.4 Gate Charge Amounts $Q_g$, $Q_{gs}$, $Q_{gd}$

In figure 1.6(a), the point up to prescribed drive voltage $V_{GS} (=XV)$ is total charge amount $Q_g$. This is the characteristic parameter that determines gate peak current $i_g(\text{peak})$ for driving the gate and drive loss $P(\text{drive loss})$.

$$i_g(\text{peak}) = \frac{Q_g}{t}$$  \hspace{1cm} \text{(1)}

$$P(\text{drive loss}) = f \cdot Q_g \cdot V_{GS}$$  \hspace{1cm} \text{(2)}

$Q_{gd}$ corresponds to mirror capacitance $C_{rss}$, and depends on power supply voltage $V_{DS}$. It is also a parameter that influences switching characteristics.

$$t_f \approx \frac{(R_s + r_g) \cdot Q_{gd}}{V_{gs(\text{on})} - V_{th}} \cdot \log \frac{V_{gs(\text{on})}}{V_{th}}$$  \hspace{1cm} \text{(3)}

Fall time $t_f$ that controls L load switching loss is expressed by equation (3). $Q_g$ and $Q_{gd}$ are important items in designing high-frequency operation loss. In high-frequency ($f = 100 \text{ kHz}$ or above) applications, it can be said that the smaller the $R_{on} \cdot Q_g$ or $R_{on} \cdot Q_{gd}$ product, the higher is the performance of the component.

![Figure 1.5 R_{DS(on)} – Tc Characteristics (2SK3418)](image)

![Figure 1.6 Input Dynamic Characteristics (2SK3418)](image)
1.4.1 Characteristics of Internal Diode between Source and Drain

In a power MOSFET, a parasitic diode is provided between the source and drain. Rated current $I_{DR}$ of this diode is the same value as forward drain current rating $I_D$.

The characteristics of this diode show the same forward voltage characteristics as an ordinary diode in the case of zero bias of the gate drive voltage ($V_{GS} = 0$). If the gate drive voltage is given positive bias (in the Nch case), as shown in Figure 1.7 there is a voltage drop determined by on-resistance $R_{DS(on)}$ ($V_{SD} = I_d \times R_{DS(on)}$) that is the same as in the forward direction, and a much lower forward voltage can be obtained even than with an SBD (Schottky barrier diode).

![Reverse Drain Current vs. Source to Drain Voltage](image)

**Figure 1.7  $I_{DR} – V_{SD}$ Characteristics (2SK3418)**

The benefits of such reverse-direction characteristics are actively applied in the following kinds of uses.

- Load switches for preventing battery reverse connection
- Switching power supply (n+1) redundant-type hot swap circuits
- Motor drive circuit external diode replacement
- Switching power supply secondary-side drive rectification circuits, etc.

1.5 Internal Diode Reverse Recovery Time $trr$ Current $I_{DR}$ Characteristic

In motor drive (power steering, starter generators, etc. in the case of electrical equipment) and switching power supply synchronous rectification applications that make positive use of a power MOSFET internal diode, there is a requirement for this reverse recovery time $trr$ to be fast. In these applications, operationally upper arm/lower arm shorting and excess turn-on loss occur in this $trr$ period. Generally, therefore, in the control circuitry, a dead time (longer than $trr$) is provided that turns off the gate signal at the time of upper/lower component switching.

![Reverse Recovery Time $trr$ Waveform](image)

**Figure 1.8  Reverse Recovery Time $trr$ Waveform**
This reverse recovery time \( trr \) shows a tendency to increase as the temperature rises. Also, the steeper \( di/dt \) at the time of recovery (area \( \text{tb} \) in figure 1.9), the more likely is the occurrence of noise, and therefore a soft recovery characteristic is desirable. Reverse recovery time \( trr \) differs greatly according to the withstand voltage of the component. In the case of a withstand voltage of 60 V or less, it is comparatively fast at a value of 40 to 60 ns. It is around 100 ns in the 100 V class, and around 300 to 600 ns in the 250 to 500 V high-withstand-voltage class. Therefore, in the high-withstand-voltage class of 250 V and above, products have been developed that have been speeded up to around 100 ns by means of lifetime control technology.

![Figure 1.9 \( trr – I_{DR} \) Characteristics (2SK3418)](image)

### 1.6 Transient Thermal Resistance Characteristic \( \theta_{ch-c}(t) \) – Pulse Width PW Characteristic

Figure 1.10 shows the \( \theta_{ch-c}(t) \)—pulse width PW characteristic. This is a characteristic for calculating channel temperature \( T_{ch} \) in the component operating state. Pulse width PW on the horizontal axis is the operating time, and 1 Shot Single Pulse repeat operation conditions are shown.

For example, \( PW = 1 \text{ ms}, \ D = 0.2 \) (duty cycle = 20%) means that the repetition frequency is 200 Hz (repetition cycle \( T = 5 \text{ ms} \)).

Generally, when channel temperature rise \( \Delta T_{ch} \) is calculated with duty cycle = 20% (\( D = 0.2 \)), \( PW = 10 \text{ ms} \), and current dissipation \( P_d = 60 \text{ W} \), the following equation may be used, but since error arises as shown below, the transient thermal resistance characteristic should be used.

\[
T_{ch} = (0.2 \times P_d) \times \theta_{ch-c} = (0.2 \times 60) \times 1.14 = 13.7^\circ C
\]

When the transient thermal resistance characteristic is used, 16.5°C error arises as shown below.

\[
T_{ch} = P_d \times \theta_{ch-c}(t) = 60 \times 0.44 \times 1.14 = 30.2^\circ C
\]

![Figure 1.10 \( \theta_{ch-c}(t) \) – Pulse Width PW Characteristics (2SK3418)](image)
Examples of channel temperature Tch calculation (2SK3418) using transient thermal resistance are shown below.

- **Example 1**
  To calculate channel temperature Tch under the following conditions: when case temperature Tc = 85°C, peak power Pd(peak)1 = 50 W, application time ts = 10 ms, 1 shot single pulse
  \[
  Tch1 = Tc + (Pd(\text{peak})1) \times \theta_{ch-c(t1)} = 85 + (50 \times 0.3 \times 1.14) = 102.1°C
  \]

- **Example 2**
  To calculate channel temperature Tch under the following conditions: when case temperature Tc = 85°C, operating frequency f = 2 kHz, repeat operation with duty cycle = 20%, applied power Pd(peak)2 = 50 W
  From the above operation, application time t2 = 100 µs, repetition cycle T = 500 µs, and D = t2/T = 0.2. Therefore:
  \[
  Tch2 = Tc + (Pd(\text{peak})2) \times \theta_{ch-c(t2/T)} = 85 + (50 \times 0.22 \times 1.14) = 97.54°C
  \]

- **Example 3**
  To calculate peak channel temperature Tch(peak) when peak power Pd(peak)3 = 500 W is further applied for a period of t3 = 60 µs by another circuit control system during the operation in Example 2
  \[
  Tch2 = Tc + (Pd(\text{peak})2) \times \theta_{ch-c(t2/T)} + (\{Pd(\text{peak})3 - Pd(\text{peak})2 \times t2/T\}) \times \theta_{ch-c(t3)}
  = 85 + (50 \times 0.22 \times 1.14) + (500 - 50 \times 0.2) \times 0.031 \times 1.14
  = 85 + 12.54 + 17.32
  = 114.86°C
  \]
1.7 Area of Safe Operation (ASO)

1.7.1 Area of Safe Operation (ASO) Diagram

Figure 1.11 shows an area of safe operation (ASO) diagram for the 2SK3418.

The ASO limited area is divided into the following 5 areas.

Area (1) is an area limited by maximum rated currents $I_{DC}$, $I_{D\text{pulse}}\text{max}$.

Area (2) is an area limited by on-resistance $R_{DS\text{on}max}$ [$I_D = V_{DS}/R_{DS\text{on}}$]. Generally, this area is divided separately from the ASO area.

Area (3) is an area limited by channel loss.

Area (4) is the same kind of secondary breakdown area as in a bipolar transistor that appears under conditions of continuous operation or opened with a comparatively long pulse width (several ms or more). This is because, when the operating voltage increases in the same applied power line, the operating current naturally decreases, but in this small current area the output transfer characteristic ($V_{gs}$-$I_d$ characteristic) is a negative temperature characteristic. When the area becomes a large current area that entails a change to a positive temperature characteristic, this phenomenon disappears. The current value at which the temperature characteristic changes from negative to positive differs from product to product, and with products of several amperes or less this phenomenon is unlikely to occur, and this can be guaranteed with a so-called constant power line with no secondary breakdown.

Area (5) is an area limited by withstand voltage $V_{DSS\text{max}}$.

![Figure 1.11 ASO Diagram (2SK3418)](image-url)
1.7.2 Notes on ASO in Circuit Control System

As power MOS FETs are generally used in switching applications, in normal operation they are usually used in limited area (2). A point requiring attention in circuit design is the control system sequence.

Figure 1.12 shows an example of the power supply voltage and gate drive voltage sequence for a terminal electronic device when the system’s source power supply is cut. As shown by the solid lines in the figure, if the fall time until power supply voltage $V_{DD}$ is turned off is longer than that for gate drive voltage $V_{GS}$, $V_{GS}$ is in an underdrive state in period $t_1$ in the figure, and enters ASO limited area (4) or (5), making it necessary to confirm whether it is in an area of safe operation. An effective means of avoiding such an operation area is to perform sequence control so that the fall time of gate drive voltage $V_{GS}$ is delayed beyond supply voltage $V_{DD}$ as shown by the dotted lines.

![Figure 12 Example of Terminal Electronic Device System Power Supply Voltage and Gate Drive Voltage Sequence](image-url)
# Power MOS FET

## Application Note

### 2. Power MOS FET Destruction Mechanisms and Countermeasures

#### Introduction

As power MOS FETs are often used in the final output circuitry of electronic device application circuits, and are used under a wide range of conditions, circuit designers frequently have to confront the problem of unexpected component destruction.

The purpose of this section is to carry out electronic circuit design with a good understanding of the mechanisms behind such destruction, and produce as far as possible problems involving heat radiation, destruction, and so forth, in mass production and in the market after design is completed, in order to use power MOS FETs effectively.

### 2.1 Relationship between Power MOS FET Application Areas and Destruction Modes

#### 2.1.1 Relationship between Main Power MOS FET Application Areas and Destruction Modes

Table 2.1 shows the relationship between main power MOSFET application areas and destruction modes. Power MOS FET destruction modes can be broadly be divided into the five modes shown below.

#### Table 2.1 Relationship between Power MOSFET Application Areas and Destruction Modes

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<td>Built-in Diode destruction</td>
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<td>3 Built-in diode destruction</td>
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<td>4 Destruction by parasitic oscillation when operating with MOS FETs connected in parallel</td>
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<td>5 Gate surge or electrostatic destruction</td>
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Guard against static electricity during handling (including electrostatic charges on the mounting equipment), and against external surges that reach to the circuit.
(1) Avalanche destruction mode
A phenomenon whereby destruction occurs if a surge voltage exceeding the rated $V_{DSS}$ of the component is applied between the drain and source, destruction voltage $V_{(BR)DSS}$ (whose value differs according to the destruction current) is reached, and a certain energy level or higher is attained. This destruction energy differs according to the individual product and operating conditions.

(2) ASO (Area of Safe Operation) destruction
Mostly caused by heat caused by exceeding the so-called Area of Safe Operation, in which component maximum rating drain current $I_d$, drain-source voltage $V_{DSS}$, or allowed channel dissipation $P_{th}(W)$ is exceeded. Main causes of heat radiation are classified as a continuous or transient factors.

1. Continuous factors:
   - Heat radiation due to DCASO (loss caused by DC power application)
   - On-resistance $R_{DSS(on)}$ loss ($R_{DSS(on)}$ increases at high temperatures)
   - Loss due to leakage current $I_{DSS}$ (extremely small compared with other loss)

2. Transient factors:
   - Pulse ASO (1 shot pulse application)
   - Load shorting ASO
   - Switching loss (turn-on, turn-off)*
   - Internal diode $trr$ loss (Upper/lower arm shorting loss)*

   All are temperature-dependent. Asterisked items also depend on operating frequency $f$.

(3) Internal diode destruction
This is a mode in which, when a parasitic diode configured between the source and drain operates, a power MOSFET parasitic bipolar transistor operates and breaks down in reverse recovery of that diode. (For details, see section 2.4, Internal Diode Destruction.)

(4) Destruction due to parasitic oscillation
This destruction mode is prone to occur in the case of parallel connection. (For details, see section 2.5, Destruction Due to Parasitic Oscillation, and section 2.6, Notes on Parallel Connection.)

(5) Gate surge, electrostatic destruction
Main types are gate overvoltage destruction caused by surge application between the gate and source from external circuitry, and gate destruction ESD (electrostatic discharge) caused by static electricity due to handling (including a charge from mounting or measuring equipment).

Table 2.1 shows the importance of the above five modes in various devices and applications, and taking these points into account when designing circuits and selecting components is an effective means of preventing various problems.

From this standpoint, the following considerations are important.
2. Power MOS FET Destruction Mechanisms and Countermeasures

2.1.2 Power MOS FET Applications and Operating Range

Figure 2.1 shows the kind of operating conditions in which power MOS FET applications are used, with load inductance and operating frequency as parameters.

![Power MOS FET Applications Diagram](image)

Figure 2.1 Power MOS FET Applications

Market requirements are (1) improved energy saving, (2) lower noise (environmental considerations), (3) smaller, thinner design.

With regard to the characteristics demanded of power MOS FETs, the most important characteristics and specifications naturally differ according to the field and application concerned.

Consequently, a demand has recently arisen for products specific to particular applications.
2.1.3 Power MOS FET Structure

Figure 2.2 shows an N-channel power MOS FET chip and its internal structure.

As shown in the figure, the internal structure of an N-channel power MOS FET chip comprises a large number of cells connected in parallel. As shown in the enlarged cell diagram, current flows in the source → drain direction (the reverse is true in a P-channel type).

![Figure 2.2 N-Channel Power MOS FET Chip and Internal Structure](image)

Figure 2.3 shows the cross-sectional structure of an N-channel power MOS FET (with gate protection diodes).

![Figure 2.3 Cross-Sectional Structure of N-Channel Power MOS FET (with Gate Protection Diodes)](image)

Figure 2.4 shows the output static characteristics and diode characteristics of a high-withstand-voltage power MOS FET (2SK1522). When a power MOS FET is used in a monitor drive, UPS (uninterruptible power supply), or similar application, the internal diode characteristics can be used effectively. The cell cross-sectional structure of a general power MOS FET plate structure is shown, together with an equivalent circuit diagram. A power MOS FET has a structure in which bipolar transistors are connected in parallel between drain and source. These transistors operate at the time of transitions, and are designed so that Rb is made small, for example, so as not to affect the MOS FET destruction tolerance.
Figure 2.4  Output Static Characteristics and Diode Characteristics (High Withstand Voltage)

Figure 2.5 shows the output static characteristics and diode characteristics of a low-withstand-voltage power MOS FET (HAT2064R) in the same way as in the previous section. Low-withstand-voltage power MOS FETs attain an ultra-low on-resistance characteristic on the order of several mΩ or less, and are therefore much smaller than a rectification Schottky barrier diode (SBD) low-V_F component (V_F = 0.4 to 0.5 V), and are widely used as MOS synchronous rectification components for the purpose of achieving higher efficiency of low-voltage power supplies (V_out = 3.3 V or less).

Figure 2.5  Output Static Characteristics and Diode Characteristics (Low Withstand Voltage)
2.2 Avalanche Destruction

2.2.1 Explanation of Avalanche Destruction
Avalanche destruction is a mode in which a flyback voltage generated when dielectric load switching operation is turned off, or a spike voltage due to leakage inductance, exceeds the power MOS FET drain rated withstand voltage, entered in a destruction area, and destruction occurs.

2.2.2 Avalanche Destruction Resistance Test Circuit and Waveform
Figure 2.6 shows an avalanche destruction resistance standard test circuit (a) and its operational waveform (b).

![Avalanche Destruction Resistance Test Circuit and Waveform](image)

Period $t_a$ in the waveform in (b) is defined as the avalanche time. The range in which drain-source peak voltage $V_{ds(p)}$ satisfies the condition $V_{ds(p)} \leq V_{ds} < V_{BRDSS}$ is an area in which the so-called rated voltage is exceeded but avalanche destruction has not been reached. In this kind of operation area, the avalanche area may or may not actually be entered depending on actual withstand voltage $V_{BRDSS}$ of the component, but it is advisable to select a product with guaranteed avalanche resistance. Avalanche resistance guaranteed products are all subjected to final screening by the standard circuit shown in (a). For avalanche resistance guaranteed products, avalanche current rated value $I_{AP(A)}$ and avalanche energy value $E_{AR(J)}$ are stipulated. $E_{AR}$ is expressed by equation (1).

$$E_{AR} = \frac{1}{2} \cdot \frac{V_{BRDSS} \cdot I_{AP}}{t_a} = \frac{1}{2} \cdot L \cdot I_{AP}^2 \cdot \frac{V_{BRDSS}}{V_{BRDSS} - V_{DD}} (J) \quad \ldots \ldots \ldots \ldots (1)$$

Also, with regard to peak channel temperature $T_{ch(peak)}$ in the avalanche operation state, use within rating channel temperature $T_{ch} \leq 150^\circ C$ is necessary. An example of calculation of this channel temperature is given in another section.
2.2.3 Avalanche Energy Calculation Method

Figure 2.7 shows an avalanche test equivalent circuit.

\[ E_{AR} = \int_0^{t_a} V_{ds}(t) \cdot I_d(t) \, dt \] ..........................(1)

Vds(t) and Id(t) are as follows:

\[ V_{ds}(t) = V_{(BR)DSS} \] ..........................(2)

\[ I_d(t) = I_{AP} - \frac{I_{AP}}{t_a} t \] ..........................(3)

\[ t_a = \frac{L \cdot I_{AP}}{V_{(BR)DSS} - V_{DD}} \] ..........................(4)

Substituting (2) and (3) in equation (1):

\[ E_{AR} = \int_0^{t_a} V_{(BR)DSS} \left( I_{AP} - \frac{I_{AP}}{t_a} t \right) \, dt = \int_0^{t_a} \left( V_{(BR)DSS} \cdot I_{AP} - \frac{V_{(BR)DSS} \cdot I_{AP} \cdot t^2}{2t_a} \right) \, dt = \frac{1}{2} \cdot V_{(BR)DSS} \cdot I_{AP} \cdot t_a \]

Substituting ta of equation (4) in the above equation:

\[ E_{AR} = \frac{1}{2} \cdot L \cdot I_{AP}^2 \cdot \frac{V_{(BR)DSS}}{V_{(BR)DSS} - V_{DD}} \]
2.2.4 Classification of Avalanche Destruction Factors

The following three factors, illustrated in figure 2.8, affect the avalanche destruction resistance value.

(1) Limitation due to drain current \( I_d \) rating
(2) Limitation due to excessive channel temperature in avalanche
(3) Decline of destruction resistance due to \( \frac{dV}{dt} \) (figure 2.6(b))

![Classification of Avalanche Destruction Factors](image-url)
### 2.2.5 Avalanche Destruction Current and Energy Value

Figures 2.9 and 2.10 show actual data show how avalanche destruction current $I_{AP}$ and avalanche destruction energy $E_{AR}$ vary with the inductance $L$ value for a high withstand-voltage 500 V class component and low withstand-voltage 60 V class component, respectively. The graphs show that as the inductance $L$ value increases, destruction current $I_{AP}$ tends to fall, but the destruction energy $E_{AR}$ value tends to increase. Therefore, to see the variations in avalanche resistance, it is necessary to consider both destruction current $I_{AP}$ and energy value $E_{AR}$. In general, it can probably be stated that an component with a small inductance value $L$ and large destruction energy value $E_{AR}$ has good avalanche resistance.

**Figure 2.9** Avalanche Destruction Current and Energy Value (High Withstand Voltage)

**Figure 2.10** Avalanche Destruction Current and Energy Value (Low Withstand Voltage)
2.2.6 Avalanche Destruction Current and \(dV/dt\) Resistance

The third factor, the relationship between avalanche destruction resistance and \(dV/dt\), will now be considered. Figure 2.11 shows measured values for avalanche destruction current \(I_{AP}\) dependence on \(dV/dt\) resistance. In a power MOS FET, as explained before, a parasitic bipolar transistor is formed between the drain and source in the structure shown in figure 2.4. As \(dV/dt\) is made steeper, a transient current flows through capacitance \(C_{ds}\), and this transistor is turned on, leading to a drop in destruction resistance. In the example in figure 2.11, the area in which \(dV/dt \leq 10 \text{ V/\mu s}\) can be called a safe area. This value differs according to the particular component.

![Test Circuit and Conditions](image)

**Figure 2.11  Avalanche Destruction Current and \(dV/dt\) Resistance**

2.2.7 Simple Determination Method for Avalanche Resistance Guaranteed Products

A simple determination method for avalanche resistance guaranteed products is described here. The description is based on the avalanche operation waveform (1 shot period) in figure 2.12, taking the example of a 2SK2869 (60 V/20 A, 45 m\(\Omega\downarrow\), DPAK package) avalanche guaranteed product as the tested device.

![Test Conditions](image)

**Figure 2.12  Avalanche Time and Drain-Source Voltage (Drain Current)**
Trial calculations have been carried out assuming that the start channel temperature $T(s)_{ch} = 60°C$ before avalanche operation (due to the channel temperature rise caused by on-resistance $R_{DS(on)}$ and switching loss). For $dV/dt$, a range of safe operation was assumed. Therefore, the following two checkpoints should be confirmed.

1. Whether avalanche current $I_{AP}$ is within avalanche guarantee value current rating $I_{AP,max}$
   (For 2SK2869 avalanche guaranteed current $I_{AP}$, when $L = 5 \text{ mH}, I_{AP,max} = 6.2 \text{ A} \ (\text{figure 2.10})$)
2. Whether channel temperature $T_{ch}$ in avalanche operation is within the range $T_{ch,max} \leq 150°C$

First, as avalanche current $I_{AP}$ in (1) is 4 A from the waveform, it can be confirmed that it is within avalanche rated current $+ I_{AP,max} \leq 6.2 \text{ A}$.

Next, channel temperature $T_{ch}$ in avalanche operation in (2) is expressed by equation (1).

$$T_{ch} = T(s)_{ch} + P_{ch} \times \theta_{ch} - c(t)$$

$$= T(s)_{ch} + \left( \frac{1}{2} \times I_{AP} \times V_{(BR)DSS} \right) \times \theta_{ch} - c(t) \quad \ldots\ldots(1)$$

Here, $\theta_{ch} - c(t)$ is transient thermal resistance, and is calculated from the 2SK2869 data sheet transient thermal resistance characteristics in figure 2.13. $\theta_{ch} - c(t = 400 \mu s)$ when avalanche opened time $t_a = 400 \mu s$ can be calculated from the graph as shown below.

$$\theta_{ch} - c(t = 400 \mu s) = \gamma(t) \times \theta_{ch} - c$$

$$= 0.08 \times 4.17$$

$$= 0.3336°C/W$$

Therefore, substituting numeric values in equation (1) gives:

$$T_{ch} = T(s)_{ch} + \left( \frac{1}{2} \times I_{AP} \times V_{(BR)DSS} \right) \times \theta_{ch} - c(t)$$

$$= 60 + \left( \frac{1}{2} \times 4 \times 80 \right) \times 0.3336$$

$$= 113.4°C$$

and it can be confirmed that $T_{ch}$ is within the $T_{ch,max} \leq 150°C$ rating.

Thus, it is determined that the value is within the avalanche guarantee range. When more complex conditions or components are involved, individual measures should be taken.
2.2.8 Avalanche Destruction Countermeasures

Figure 2.14 shows avalanche destruction countermeasures (methods of suppressing surge voltages).

In avalanche destruction, destruction is caused by a counter voltage due to floating inductance (inductance load). As a characteristic after destruction, electrodes are shorted. There are three countermeasures for avalanche destruction, as follows.

1. Make large-current path wiring as short and thick as possible to reduce floating inductance.
2. Insert a gate series resistance $R_g$, and suppress $dV/dt$. As a surge voltage occurs when switching off, surge voltages are suppressed by making the value of turn-off constant $R_g$ large, but if the value is made too large, switching loss will increase. This should be considered when deciding on the circuit constant.
3. Insertion of CR snubber and Zener diode

When a surge absorption snubber, etc., is inserted, the wiring should be made short and thick, and connection should be made directly to the power MOS FET drain and source terminals.

2.3 ASO Destruction (Heat Radiation Design)

2.3.1 Explanation of ASO Destruction

ASO destruction refers to a mode in which heat radiation is caused instantaneously and locally, and destruction occurs, when an overcurrent and the used voltage are applied simultaneously due to load shorting, etc., that does not occur in normal operation. It also refers to a mode in which the channel temperature rises excessively due to continuous heat radiation, thermal runaway occurs, and destruction results, when chip heat radiation is not performed properly due to thermal mismatching or a high repetition frequency.

2.3.2 ASO Destruction Countermeasures

Figure 2.15 illustrates ASO destruction and countermeasures.
There are three countermeasures, as follows.

(1) Check inclusion within the forward bias ASO (Area of Safe Operation) guarantee, and that the temperature derating is adequate.

(2) If load shorting is predicted, insert an overcurrent protection circuit.

If the designed drain load current is exceeded, the voltage arose on Rs is detected, MOS FET Q1 is turned on, shorting occurs between G-S of the main power MOS FET via R3, and it is turned off. In this case, the value of R3 is made larger than R1 determined as a normal switching off time constant, and is made a constant that prevents the occurrence of surge at the time of overcurrent (cutoff) protection. Alternatively, it is possible to perform cutoff control of speed at the time of cutoff in a list by means of Q1 gate resistance Rg. MOS FET gate-source drive voltage $V_{GS}$ in normal operation is expressed by equation (1).

$$V_{GS} = V_{in} \times \frac{R3 + 10k\Omega}{R3 + 10k\Omega} + \frac{R1 + R2}{R3 + R1 + R2}$$ ..................................(1)

$V_{GS}$ is set to a value ($V_{GS} = \text{approx.} 10\ V$) at which a power MOS FET operates fully in the on-resistance region. Gate retention voltage $V_{GS(\text{cut})}$ at the time of overcurrent cutoff is expressed by equation (2).

$$V_{GS(\text{cut})} = V_{in} \times \frac{R3}{R1 + R2 + R3}$$ ..................................(2)

$V_{GS(\text{cut})}$ must be set to a value smaller than power MOS FET gate-source cutoff voltage $V_{GS(\text{off})}$. The $V_{GS(\text{off})}$ temperature characteristic ($\alpha = -5\ \text{mV/°C}$) is also taken into consideration.

(3) Carry out radiation design allowing a sufficient margin.

This is covered in the practical example of radiation design.

### 2.3.3 Forward Bias ASO (Area of Safe Operation)

Figure 2.16 shows a forward bias ASO graph (2SK3082) and the corresponding temperature derating method. (For information on an Area of Safe Operation (ASO), refer to the description of the use of power MOS FET characteristics described earlier.)

**Figure 2.16 Forward Bias ASO Diagram (Area of Safe Operation)**

With regard to the ASO temperature derating method, PW = 10 $\mu$s, Tc = 75°C derating will be described as an example.

First, regarding PW = 10 $\mu$s and Tc = 25°C guarantee values, this ASO diagram gives a Pd(25) = 1500 W (= $V_{ds} \times I_{D} = 50\ V \times 30\ A$) power line. Then, as Tc = 75°C derating ratio D = 60%,

$$Pd(75) = Pd(25) \times 0.6$$

$$= 1500 \times 0.6$$

$$= 900\ W$$

In the ASO diagram, this is the area indicated by the PW = 10 $\mu$s, Tc = 75°C line in figure 2.16.
2.3.4 Load Shorting Resistance and Countermeasures

Figure 2.17 shows power MOS FET load shorting resistance (examples of the 2SK1518 and 2SK1522).

When a power MOS FET is used in a motor drive application, if the load should short, it is necessary to be able to withstand the conditions without breaking down until the overcurrent protection circuit operates.

1. As shown in figure 2.17, this load shorting resistance is dependent on the power supply voltage $V_{DD}$ ($\approx V_{DS}$) used, with destruction occurring in a shorter time the greater the value of $V_{DS}$ (as the power applied due to load shorting increases). This destruction time differs from product to product, but the overcurrent protection detection time in the event of load shorting should be set to between 1/2 and 1/3 or less of the destruction time.

2. Next, when load shorting occurs, as the short-circuit current an overcurrent of around 5 to 10 times the normal operation current flows, and this is cut off.

A point to be noted here is the surge voltage that is generated when this overcurrent is cut off. This is showed as the waveform in figure 2.17. As a current considerably larger than the steady state current flows, it is necessary to set a cutoff turn-on time slower than the steady state on/off speed, and suppress the cutoff surge voltage to the component’s rated voltage $V_{DSS}$ or less.

![Diagram](image_url)

**Figure 2.17** Power MOS FET Load Shorting Resistance and Countermeasures

2.3.5 Heat Radiation Design

When carrying out mounting design for power devices, it goes without saying that cooling technology — that is, how heat is to be radiated efficiently under various environmental conditions — is an important consideration, but how to perform theoretical heat calculations efficiently is also important. Examples are given here of practical heat radiation design in which the operating channel temperature of a power MOS FET can be calculated theoretically.

1. Preconditions when using a 2SK1170 (500 V/20 A, 0.27 Ω, TO-3P) are shown below.

   (1) Operating conditions
      — Ambient temperature $T_a = 50^\circ C$
      — Operating current $I_d = 8 A, 10 A$ (2 conditions)
      — $PW = 10 \mu s, duty = 50\%$ max ($f = 50 kHz$ operation)
      — Switching loss $P(t_f) = 500 W$, $t_f = 0.2 \mu s$ (ton loss is omitted here)

   Design target: $T_{ch} \leq 120^\circ C$
(2) Heat sink thermal resistance \( \theta_{f-a} \): 3 kinds: (I) 0.5°C/W, (II) 1.0°C/W, (III) 1.5°C/W

(3) Mounting method: Insulating mica used, silicon grease used

\[ (\theta(i) + \theta(c)) = 0.8°C/W \]

where \( \theta(i) \): Insulating mica thermal resistance
\( \theta(c) \): Contact thermal resistance

**Table 2.2 Thermal Resistance of Various Transistor Packages**

<table>
<thead>
<tr>
<th>Thermal Resistance</th>
<th>Package</th>
<th>DPAK</th>
<th>TO-220AB</th>
<th>LDPAK</th>
<th>TO-220FM</th>
<th>TO-3P</th>
<th>TO-3PFM</th>
<th>TO-3PL</th>
</tr>
</thead>
<tbody>
<tr>
<td>( R_{th(ch-c)} )</td>
<td>°C/W</td>
<td>178</td>
<td>80</td>
<td>83.3</td>
<td>62.5</td>
<td>55</td>
<td>42</td>
<td>45</td>
</tr>
<tr>
<td>((R_{th(i)} + R_{th(c)}))</td>
<td>°C/W</td>
<td>0.3 to 0.6</td>
<td>0.3 to 0.5</td>
<td>0.3 to 0.5</td>
<td>0.4 to 0.6</td>
<td>0.1 to 0.2</td>
<td>0.3 to 0.5</td>
<td>0.1 to 0.2</td>
</tr>
<tr>
<td>No insulation plate</td>
<td>With silicon grease</td>
<td>2.0 to 2.5</td>
<td>1.5 to 2.0</td>
<td>1.5 to 2.0</td>
<td>1.5 to 2.0</td>
<td>0.5 to 0.9</td>
<td>1.0 to 1.5</td>
<td>0.4 to 0.5</td>
</tr>
<tr>
<td>Mica insertion ( (t = 50 \text{ to } 100\mu m) )</td>
<td>With silicon grease</td>
<td>—</td>
<td>2.0 to 2.5</td>
<td>—</td>
<td>—</td>
<td>0.5 to 0.8</td>
<td>—</td>
<td>0.5 to 0.7</td>
</tr>
<tr>
<td>No insulation plate</td>
<td>With silicon grease</td>
<td>—</td>
<td>4.0 to 6.0</td>
<td>—</td>
<td>—</td>
<td>2.0 to 3.0</td>
<td>—</td>
<td>1.2 to 1.5</td>
</tr>
</tbody>
</table>

Note: 1. Reference value

Based on these preconditions, a design target channel temperature of \( T_{ch} \leq 120°C \) is set.

2. In this method, allowable power dissipation characteristics under various heat radiation conditions (1) and the power dissipation \( P_D \) characteristic according to a rise in the power MOS FET channel temperature (2) are calculated, and the point of intersection at which functions (1) and (2) overlap is taken as the channel temperature in the saturation state to be found. Results calculated on the basis of the above operating and environmental usage conditions are shown in figure 2.18.
The procedure to reach figure 2.18 is described below.
3. With reference to the contents of the box below, allowable power dissipation characteristics under the 
aforementioned various heat radiation conditions (1) and the power MOS FET power dissipation characteristic (2) 
are calculated. In the calculation of power MOS FET power dissipation \( P_D \), power MOS FET on-resistance 
temperature coefficient \( \alpha \) (coefficient when \( T_{ch} = 25^\circ C \) is taken as 1.0) can be read beforehand from the Ron-Tc 
characteristic of the individual data sheet, and that value entered on the horizontal axis as in table 2.3. Table 2.3 
shows the calculation results.

- Calculate and plot allowable power dissipation straight line \( P_{D(0)} \) under each heat radiation condition ((1) in figure)
  First, find total thermal resistance \( \theta_{(ch-a)} \) under each heat radiation condition.
  \[ \theta_{(ch-a)} = \theta_{(ch-c)} + (\theta_i + \theta_c) + \theta_f \]  ……………… (1)
  From equation (1), \( \theta_{(ch-a)} \) when using (I) heat sink is as follows:
  \( \theta_{(ch-a)} = 1.04 + 0.8 + 0.5 = 2.34^\circ C/W \) (Similarly for (II) = 2.84°C/W, (III) = 3.34°C/W)
  Allowable power dissipation \( P_{D(0)} \) is expressed by equation (2). Three points can be used for the allowable loss 
curve.
  \[ P_{D(0)} = \frac{T_{ch} - T_a}{\theta_{(ch-a)}} \]  ……………… (2)
  Under condition (I), assuming \( T_{ch} = 50, 100, 150^\circ C \) gives 0W, 21.4 W, 42.7 W respectively \( (= \frac{(150 - 50)}{2.34}) \)
  Calculation can be performed for the 2 conditions (II) and (III) in the same way, and 3 straight lines plotted.
- Calculate and plot power MOS FET power dissipation curve \( P_{D(M)} \) ((2) in figure)
  Power MOS FET on-resistance \( R_{DS(on)} \) has a positive temperature characteristic.
  That is to say, there is a curvilinear rise (as shown in individual catalogs) as \( T_{ch} \) rises.
  When power MOS FET total power dissipation \( P_{D(M)} \) accompanying the temperature rise when \( I_D = 8A, 10A \) is 
found, taking this point into consideration, 2 curves can be drawn.

### Table 2.3 Calculation of Power MOS FET Power Dissipation \( P_{D(M)} \) (Example of 2SK1170)

<table>
<thead>
<tr>
<th>Item</th>
<th>( T_{ch}(^\circ C) )</th>
<th>25</th>
<th>40</th>
<th>60</th>
<th>80</th>
<th>100</th>
<th>120</th>
<th>140</th>
<th>150</th>
<th>Notes</th>
</tr>
</thead>
<tbody>
<tr>
<td>( R_{DS(on)} ) temperature coefficient ( \alpha ) for ( T_{ch} = 25^\circ C )</td>
<td>1.0</td>
<td>1.09</td>
<td>1.27</td>
<td>1.5</td>
<td>1.73</td>
<td>2.0</td>
<td>2.27</td>
<td>2.41</td>
<td>( R_{DS(on)} ) See Ron-Tc characteristic in individual data sheet</td>
<td></td>
</tr>
<tr>
<td>MOS power dissipation</td>
<td>On-resistance loss ( P_{ON} = I_D^2 \cdot R_{DS(on)} )</td>
<td>( I_D = 8A )</td>
<td>8.64</td>
<td>9.4</td>
<td>11.0</td>
<td>13.0</td>
<td>14.9</td>
<td>17.3</td>
<td>19.6</td>
<td>20.8</td>
</tr>
<tr>
<td></td>
<td>( I_D = 10A )</td>
<td>13.5</td>
<td>14.7</td>
<td>17.1</td>
<td>20.3</td>
<td>23.4</td>
<td>27</td>
<td>30.6</td>
<td>32.5</td>
<td>( R_{DS(on)} ) See Ron-Tc characteristic in individual data sheet</td>
</tr>
<tr>
<td></td>
<td>Switching loss *1 ( P_S = \frac{I_D^2 \cdot \alpha}{T_f(t)} )</td>
<td>5</td>
<td>5</td>
<td>5</td>
<td>5</td>
<td>5</td>
<td>5</td>
<td>5</td>
<td>5</td>
<td>Note operating frequency dependence</td>
</tr>
<tr>
<td>Total power dissipation ( P_{D(M)} = P_{ON} + P_S )</td>
<td>( I_D = 8A )</td>
<td>13.6</td>
<td>14.4</td>
<td>16.0</td>
<td>18.0</td>
<td>19.9</td>
<td>22.3</td>
<td>24.6</td>
<td>25.8</td>
<td>See separate section for detailed calculation of R, L load Ron loss, SW loss</td>
</tr>
<tr>
<td></td>
<td>( I_D = 10A )</td>
<td>18.5</td>
<td>19.7</td>
<td>22.1</td>
<td>25.5</td>
<td>28.4</td>
<td>32.0</td>
<td>35.6</td>
<td>37.5</td>
<td>Note operating frequency dependence</td>
</tr>
</tbody>
</table>

Note: 1. For the sake of simplicity, the same \( P_S \) value is used for both \( I_D = 8A \) and \( 10A \).

4. In this way, the graph of channel temperature \( T_{ch} \) vs power dissipation \( P_D \) in figure 2.18 is created.
  First, plot allowable loss characteristic (1) under each heat radiation condition.
  As ambient temperature \( T_a = 50^\circ C \) has been assumed, taking \( T_{ch} = 50^\circ C \) as the zero point (as \( T_{ch} = 50^\circ C \) is 0 W),
  and individual allowable loss characteristics can be drawn for the use of 3 kinds of heat sinks. Next, power MOS 
  FET power dissipation (at \( I_D = 8A, 10A \) calculated in table 4 is drawn, completing the process.
5. The way of interpreting figure 2.18 (considering the calculation results) and appropriate measures are described below.

- Considering Tch-PD graph results
  (a) Points of intersection (B), (C), (D), and (E) represent channel temperature Tch in a state of thermal equilibrium under the respective conditions.
  That is to say, the only conditions that satisfy target design Tch ≤ 120°C are I_D = 8 A heat radiation conditions (I) and (II). (Points (C) and (D))
  (b) When point-of-intersection channel temperature Tch is 150°C or above, the maximum rating is exceeded.
  (c) Also, when both loss characteristic points of intersection are absent, as with the heat sink (III) condition, this means that thermal runaway*1 occurs and destruction results.

Note: 1. **Tch rise** → **Ron increase** → **Loss increase** → **Tch rise and thermal destruction**

- Provision for design value Tch ≤ 120°C
  (a) Operating current I_D is made 8 A max and heat radiation condition (I) or (II) is applied. (Design target Tch is satisfied by (C) and (D)).
  (b) In case of use up to operating current I_D = 10 A max, the following points (combinations), etc., should be considered and a review conducted.
    1) Use a heat sink with smaller thermal resistance than (I). (Improve heat radiation conditions and lower θ(ch-a).
    2) Lower θ(ch-c) by changing the component package. Example: TO-3P/2SK1170 → TO-3PL/2SK1629
    3) Change MOS FET to a one class higher low-on-resistance component. However, with high-speed operation (f = 100 kHz or higher), switching loss P(tf) must also be considered (as there is generally a trade-off between on-resistance Ron and switching time tf).

6. Figure 2.19 gives further information on the method of use and points for attention concerning figure 2.18.
   Tables 2.4 and 2.5 show power MOS FET loss calculation equations and calculation methods.
   Figure 2.20 show the calculation method for peak channel temperature Tch(peak) and thermal resistance θch-c(PW/T) in repeat operation.

---

**Figure 2.19  Relationship between Channel Temperature Tch and Power Dissipation P_D**
### Table 2.4 Power MOS FET Loss Calculation

<table>
<thead>
<tr>
<th>Category</th>
<th>Operating Waveform</th>
<th>No.</th>
<th>Operation Period</th>
<th>Average Loss Calculation</th>
</tr>
</thead>
<tbody>
<tr>
<td>Resistance R load</td>
<td><img src="image1.png" alt="Image" /></td>
<td>1</td>
<td>tr period Ptr</td>
<td>(Pt_r = \frac{1}{6} (V_ds \cdot I_d + 2I_d^2 \cdot R_{on} \cdot \alpha) \frac{t_r}{T}) Smaller than term 1 and can be ignored.</td>
</tr>
<tr>
<td></td>
<td></td>
<td>2</td>
<td>ton period Pton</td>
<td>(P_{ton} = I_d^2 \cdot R_{on} \cdot \frac{t_{on}}{T})</td>
</tr>
<tr>
<td></td>
<td></td>
<td>3</td>
<td>tf period Ptf</td>
<td>(P_{tf} = \frac{1}{6} (V_ds \cdot I_d + 2I_d^2 \cdot R_{on} \cdot \alpha) \frac{t_f}{T}) Smaller than term 1 and can be ignored.</td>
</tr>
</tbody>
</table>

Note: 1. \(\alpha\): Ron thermal coefficient \(= \frac{T(x^\circ C)}{T(25^\circ C)}\)

### Table 2.5 Examples of Power MOS FET Loss Calculation (for Reference)

<table>
<thead>
<tr>
<th>Category</th>
<th>Operating Waveform</th>
<th>Loss Calculation (Ron thermal coefficient (\alpha) omitted)</th>
</tr>
</thead>
<tbody>
<tr>
<td>Resistance R load</td>
<td><img src="image2.png" alt="Image" /></td>
<td>(P_{tf} = \frac{1}{T} \int_0^{t_f} V_ds(t) \cdot I_d(t) , dt)</td>
</tr>
<tr>
<td></td>
<td></td>
<td>(= \frac{1}{T} \left( \left[ \frac{V_ds - I_d \cdot R_{on}}{t_f} \right]_0^{t_f} + \frac{I_d}{t_f} \right) dt)</td>
</tr>
<tr>
<td></td>
<td></td>
<td>(= \frac{1}{T} \left( I_d^2 \cdot R_{on} \cdot \frac{I_d}{t_f}^{t_f} \right) + \left( \frac{I_d}{t_f} \right)^2 + \frac{I_d \cdot V_ds - 2I_d^2 \cdot R_{on}}{2t_f} \cdot t_{tf} \cdot I_d \cdot \alpha)</td>
</tr>
<tr>
<td></td>
<td></td>
<td>(\therefore P_{tf} = \frac{1}{T} \left[ (V_ds \cdot I_d) + 2I_d^2 \cdot R_{on} \right] \frac{t_f}{T})</td>
</tr>
</tbody>
</table>

### Inductance L load

<table>
<thead>
<tr>
<th>Category</th>
<th>Operating Waveform</th>
<th>Loss Calculation (Ron thermal coefficient (\alpha) omitted)</th>
</tr>
</thead>
<tbody>
<tr>
<td></td>
<td><img src="image3.png" alt="Image" /></td>
<td>(P_{ton} = \frac{1}{T} \int_0^{t_{on}} I_d^2(t) \cdot R_{on} , dt)</td>
</tr>
<tr>
<td></td>
<td></td>
<td>(= \frac{1}{T} \int_0^{t_{on}} \left( \frac{I_a - I_a \cdot 2I_b}{t_{on}} \right)^2 + 2 \left( \frac{I_b + I_a}{t_{on}} \right)^2 + \frac{I_a - I_b}{t_{on}} \cdot I_a \cdot \alpha \cdot t_{on} \cdot \frac{t_{on}}{T} )</td>
</tr>
<tr>
<td></td>
<td></td>
<td>(= \frac{1}{T} \left[ \left( \frac{I_d^2}{3t_{on}^2} \cdot R_{on} \cdot V_ds \right) \right] + \left( \frac{I_a - I_b}{t_{on}} \right) \cdot I_a \cdot I_b \cdot \alpha \cdot t_{on} \cdot \frac{t_{on}}{T} ) (\therefore P_{ton} = \frac{1}{3} (I_a^2 + I_b \cdot I_b) \cdot R_{on} \cdot \frac{t_{on}}{T})</td>
</tr>
</tbody>
</table>
(6) Repetition frequency $T_{ch(peak)}$, thermal resistance $\theta_{ch-c}(PW/T)$

$$T_{ch(peak)} = T_c + \Delta T_{ch} = T_c + P_d \left( \frac{PW}{T} \theta_{ch-c} + \left(1 - \frac{PW}{T} \right) \theta_{ch-c}(PW) \right)$$ \hspace{1cm} (1)

$$\frac{PW}{T} \theta_{ch-c} = \frac{T_{ch(peak)} - T_c}{P_d} = \frac{\Delta T_{ch}}{P_d}$$ \hspace{1cm} (2)

From equations (1) and (2):

$$\theta_{ch-c}(PW) = \theta_{ch-c} \left( \frac{PW}{T} \right) + \left(1 - \frac{PW}{T} \right) \theta_{ch-c}(PW)$$ \hspace{1cm} (3)

Normalized transient thermal resistance $\gamma_s(PW) = \frac{\theta_{ch-c}(PW)}{\theta_{ch-c}}$ \hspace{1cm} (4)

Repetition duty cycle $n(\%) = \frac{PW}{T} \times 100$ \hspace{1cm} (5)

From equations (4) and (5), thermal resistance $\theta_{ch-c}(PW/T)$ for a pulse of width $t = PW$ and period of one repetition $T$ is given by equation (6):

$$\theta_{ch-c}(PW) = \theta_{ch-c} \left( \frac{n}{100} \right) + \left(1 - \frac{n}{100} \right) \gamma_s(PW)$$ \hspace{1cm} (6)

Here, $\theta_{ch-c}$ is a dc thermal resistance.

### 2.4 Internal Diode Destruction

#### 2.4.1 Explanation of Internal Diode Destruction

Internal diode destruction is a destruction mode that occurs when the parasitic diode between the drain and source of a power MOS FET is used actively. It is limited to use in DC/AC inverters utilized in motor control, uninterruptible power supply (UPS), and similar H bridge circuits.

Internal diode destruction occurs only in the above uses, and applies especially to components with a withstand voltage of 250 V or above used at high voltages, but in recent years the destruction mechanism has been clarified, and component diode destruction resistance has been improved. With most 250 to 600 V high-withstand-voltage AP3-H, AP3-HF (internal high-speed diode), and AP4-H series products, destruction countermeasures are incorporated into the component design. From an application standpoint, the AP3-H and AP5-HF series are recommended for these uses. With components with a low withstand voltage of 100 V or below, this destruction problem almost never occurs as the voltage used is also low.
Figure 2.21 shows an inverter circuit using general power MOS FETs and the power MOS FET operation waveform in a full bridge circuit. In this circuit, Q1 and Q4 operate and PWM control is performed by the Q1 component. Q4 is always on during the Q1 PWM control period. When Q1 current $I_{D1}$ flows and is then turned off, motor inductance $L$ regenerative current $I_F$ flows through the Q2 internal diode. When Q1 is turned on again in this state, due to the influence of Q2 internal diode reverse recovery time $t_{rr}$, in this period Q1 and Q2 enter the conduction state, short-circuit current $i_{rr}$ flows and recovers, and at the same time the internal diode voltage ($V_{DS}$) also recovers.

![Figure 2.21 Power MOS FET Operation in Full Bridge](image)

Figure 2.22 shows the structure and equivalent circuit of a power MOS FET. As shown in this figure, an internal diode is formed between the source and drain structurally, and is also called a parasitic diode.

![Figure 2.22 Power MOS FET Component Structure and Equivalent Circuit](image)
Figure 2.23 shows the internal diode destruction mechanism. As stated earlier, internal diode destruction resistance has improved considerably, and structural measures have been taken to inhibit parasitic bipolar transistor operation, so that the problem of destruction almost never occurs during normal use.

Destruction occurs while the diode voltage is recovering. If di/dt changes sharply during the reverse recovery of diode, an excess recovery current flows and dV/dt rises sharply during the reverse recovery period (period B), and this makes the parasitic bipolar transistor between the drain and the source turn on in part of the cells around the gate or source electrode and may lead to destruction of the diode. When the damaged product is disassembled and examined, traces of the destruction are visible around the gate or source electrode.

In P-channel products, parasitic PNP transistors have lower carrier mobility and a lower hfe than NPN transistors. Therefore, the PNP transistors do not turn on as easily and destruction more seldom occurs.

Figure 2.24 shows examples of internal diode destruction circuit countermeasures (usage precautions).

1. Increase gate resistance Rg of the MOS on the PWM control side to reduce di/dt when the diode is short-circuited, and to reduce irr (thus reducing dV/dt)
2. Reduce the wiring inductance of the circuit to reduce dV/dt and the voltage spike during diode recovery.
3. Insert a snubber circuit to reduce dV/dt and the voltage spike during diode recovery.

Figure 2.24 Examples of Internal Diode Destruction Circuit Countermeasures
Figure 2.25 shows actual data before and after countermeasures for internal diode destruction resistance of 500 V high-withstand-voltage components (now discontinued).

Test conditions:
- \( V_{CC} = 350 \text{ V} \)
- \( V_{GD} = +15\text{V}, -10\text{V} \)
- \( PW = 10\mu\text{s}(1\text{shot}) \)
- \( T_c = 25^\circ\text{C} \)

Note: The relationship between gate resistance \( R_g \) and \( di/dt \) or \( dV/dt \) depends on the voltage used and the wiring inductance of the application system.
Check the waveform in the actual application.

2.5 Destruction Due to Parasitic Oscillation

2.5.1 Explanation of Destruction Due to Parasitic Oscillation

Gate parasitic oscillation mainly occurs when power MOS FETs are connected in parallel and are directly connected without inserting a gate resistance. This parasitic oscillation occurs in a resonant circuit formed by gate-drain capacitance \( C_{gd(Crss)} \) and gate lead inductance \( L_g \) when the drain-source voltage is turned on and off at high speed. When the resonance condition \( (\omega L = 1/\omega C) \) occurs, an oscillation voltage much larger than drive voltage \( V_{gs(in)} \) is generated in \( V_{gs} \) between the gate and source, as a result of which gate destruction occurs due to a voltage exceeding the gate-source rated voltage, or the oscillation voltage when the drain-source voltage is turned on and off is superimposed on the \( V_{gs} \) waveform via gate-drain capacitance \( C_{gd} \) and positive feedback occurs, leading to oscillation destruction due to mal operation.
2.5.2 Power MOS FET Parasitic Oscillation Mechanism

Figure 2.26 shows a parallel equivalent circuit.

The voltage oscillation due to resonance changes in proportion to the selectivity Q(=ωL/R=1/ωCR) of the resonant circuit: voltage Vc generated at capacitance C is given by equation (1) and voltage VL generated at inductance L is given by equation (2).

\[
V_c = \frac{1}{2\pi f C} \cdot I = \frac{1}{\omega CR} V = QV \quad \cdots \cdots (1)
\]

\[
V_L = \frac{2\pi f L}{\omega L/R} \cdot I = \frac{\omega L}{\omega CR} V = QV \quad \cdots \cdots (2)
\]

Here, \( Q = \frac{\omega L}{R} = \frac{1}{\sqrt{LC/R}} \)

Resonance frequency \( f_r = \frac{1}{2\pi \sqrt{LC}} \)

When power MOS FET parallel connection is performed by means of direct connection without using a gate series resistance, a parasitic oscillation waveform appears in the gate. With this parasitic oscillation, oscillation voltage \( V_{ds(p)} \) passes through gate-drain capacitance \( C_{gd}(Crss) \) due to load wiring inductance \( L_d \) when the drain-source voltage is turned on and off at high speed, and particularly when it is turned off, and a resonant circuit with gate lead inductance \( L_g \) is formed. As gate internal resistance \( r_g \) of a large-current, high-speed power MOS FET is extremely small, at 1 to 2 Ω, when there is no gate external resistance \( R_g \), oscillation circuit \( Q \) — that is \( \sqrt{L/C/R} \) — becomes large, and when the resonance condition occurs, a large oscillation voltage is generated between that point and \( C_{gd}(Crss) \) or \( L_g \) (that is to say, between the MOS gate and source), and parasitic oscillation is caused.

In particular, as large-current operation is performed in the case of parallel connection, if transient current balance becomes poor when switching off, all the currents flow in one MOS FET in a period with deviation of this timing. Generally, this period is an extremely short time of several ns to several tens of ns, and therefore power MOS FET thermal stress is not a problem, but drain-source oscillation voltage \( V_{ds(p)} \) may be logically \( n \) times greater than this or more (as \( L_d \) also appears to be larger due to the skin effect since a high-frequency large current actually flows in a transition).

Skin effect: Phenomenon whereby a high-frequency current flows only through the surface of a conductor, and not through the inner part. When current flows in a conductor, a magnetic flux is generated around the current, and as this crossing with the current, an inductance effect is produced. When a current is passed through a thick conductor that handles large currents, a magnetic flux is also generated in the conductor, and therefore the inductance effect is more intense toward the center of the conductor. Consequently, when a high-frequency current flows in a thick conductor, there is a strong inductance effect in the central part, making it difficult for current to pass through, and current deviates toward the surface of the conductor. In this case, the cross-sectional area through which the current flows is reduced, and thus viewed from outside, electrical resistance — that is, inductance — appears to be large.
Figure 2.27 shows parasitic oscillation and destruction countermeasures in the case of parallel connection.

**Figure 2.27   Parasitic Oscillation Reduction and Destruction Countermeasures**

### 2.6 Notes on Parallel Connection

Notes on mounting covering precautions concerning parallel connection, and advice on the selection and use of power MOS FET components, are given below.

#### 2.6.1 Notes on Mounting

- Low-inductance wiring
- Make drain and source wiring lengths equal, and use twisted-pair wiring, etc.
- Pay attention to parasitic oscillation (see attachment on parasitic oscillation countermeasures)

#### 2.6.2 Advice on Selection and Use of Power MOS FETs

Discussion and agreement with the semiconductor manufacturer are necessary.

<table>
<thead>
<tr>
<th>Action</th>
<th>Result</th>
</tr>
</thead>
<tbody>
<tr>
<td>Align $V_{th}(V_{GS(off)})$ value (higher value preferable)</td>
<td>Off-time transient current balance reduction</td>
</tr>
<tr>
<td>Align on-resistance $R_{DS(on)}$</td>
<td>On current balance reduction</td>
</tr>
<tr>
<td>Apply adequate gate drive voltage ($4 \text{ V drive product: } V_{GS} = 5 \text{ to } 10 \text{ V}, \ 10 \text{ V drive product: } V_{GS} = 10 \text{ to } 12 \text{ V}$)</td>
<td>Heat radiation balance reduction</td>
</tr>
<tr>
<td>Avoid avalanche operation as far as possible</td>
<td>Current concentration in low-withstand-voltage components</td>
</tr>
</tbody>
</table>
2.7 Electrostatic Destruction

2.7.1 Explanation of Electrostatic Destruction
Electrostatic destruction refers to destruction due to static electricity or a surge voltage from a human body or equipment when a product is handled or is being mounted.

2.7.2 Electrostatic Destruction Countermeasures
Figure 2.28 shows countermeasures against electrostatic destruction.

**Figure 2.28 Electrostatic Destruction Countermeasures**

In electrostatic destruction, the gate oxide film is destroyed when static electricity or a surge voltage generated by a human body, mounting equipment, etc., is applied to a gate. Characteristics seen after destruction are a voltage drop or shorting between the gate and source, shorting between the drain and source, or increased leakage current. (See figure 2.29.)

The following three methods are used as countermeasures to electrostatic destruction.

1. Earth human bodies via a 1 MΩ resistance before handling devices.
2. Ensure that equipment is properly earthed.
3. To prevent the application of gate surge voltages that may occur after board mounting, insert a gate resistance and Zener diode.
2.7.3 Destruction Progression Modes after Electrostatic Destruction

In figure 2.29, post-gate-destruction characteristic modes are broadly classified into two kinds, and their respective natures are illustrated if the respective destruction products maybe adopted to a set circuit.

- **Damaged product A**
  - Between gate and source: short-circuit
  - Between drain and source: short-circuit
  - The product will not operate as MOS FET.
  - The system will not operate.

- **Electrostatic destruction**

- **Damaged product B**
  - Between gate and source: decrease in impedance (several hundred Ω to several kΩ)
  - Between drain and source: increase in current leakage
  - The product operates as MOS FET.
  - The system operates.
  - Operation continues with a reduced gate impedance.
  - RDS(on) rises.
  - More heat is generated in MOS FET.
  - ASO destruction of the product

**Figure 2.29  Destruction Progression Modes after Electrostatic Destruction**

Figure 2.30 illustrates the characteristic modes of destruction products A and B. In the destruction product A mode, there is almost complete shorting between the gate and source and between the drain and source. In the destruction product B mode, although a certain level of resistance (several tens of Ω or more) is maintained between the gate and source, and a curve shape of standing to reverse voltage is keeping although leakage current $I_{DSS}$ between the drain and source is large at several hundred mA to several tens of mA.

**Figure 2.30  Sample Electrostatic Destruction Product $V_{GSS}$ and $V_{DSS}$ Waveforms**
2.7.4 Mechanism whereby Gate Destruction Product B Come to ASO Destruction

When the destruction product A mode is temporarily incorporated in a set circuit, the circuit naturally does not operate, a short-circuit current flows between the MOS FET gate and source when power is turned on, and destruction traces increase.

When a mode such as the destruction product B mode is temporarily adopted to a set circuit, since drain-source withstand voltage is maintained (although when leakage current IDSS is large, power consumption increases in the off state and causes a rise in component temperature), according to the circuit gate signal source resistance Rs constant and gate-source resistance RGS immediately after destruction, a voltage with drive capability is applied between the gate and source, so that although drive voltage VGS appears to fall, switching operation is performed. This state is illustrated in figure 2.31.

![Figure 2.31 Mechanism whereby Gate Destruction Product B Reaches ASO Destruction](image)

When, for example, a destroyed product B mode gate destruction sample with gate-source resistance value RGS = 100 Ω immediately after gate destruction and drain-source leakage current IDSS = 1 mA is temporarily incorporated in an operating circuit with power supply voltage VDD = 24 V, gate input voltage Vin = 10 V, gate signal source resistance Rs = 22 Ω, and on-duty D = 0.3, when the actual gate drive voltage VGS and off-time power consumption Poff of this component are calculated, VGS = 8.2 V and Poff = 16.8 mW as shown below, and generally, in the case of a logic-level drive component, the component operates adequately.

\[
V_{GS} = \frac{R_{GS}}{R_s + R_{GS}} \times V_{in} = \frac{100}{22 + 100} \times 10 \approx 8.2V
\]

\[
P_{off} = V_{DD} \times I_{DSS} \times (1 - D) = 24 \times 1 \times 10^{-3} \times 0.7 = 16.8mW
\]

However, as gate-source resistance value RGS of this destroyed product may well decrease further, in that process gate drive voltage VGS becomes insufficient. As a result, on-resistance increases (a complete on-resistance operation on-state is not established, and operation is performed in a state in which V\textsubscript{DS(on)} has increased as shown in figure 2.31), and power consumption increases, and eventually component ASO destruction occurs.

In a case such as this, subsequent analysis of the destroyed product shows a close resemblance to thermal destruction due to exceeding of the component ASO, but it is possible that the destruction mode constituting the initial trigger was a gate destruction mode. However, it is extremely difficult to determine whether it is the latter case or not by destroyed product because destruction traces have increased.

Therefore, at the very least, care must be taken in handling (including component measurement) up to embedding in a circuit.
2.8 Usage Notes

2.8.1 Power MOS FET Main Loss Frequency Dependence and Relationship to Main Characteristics

Figure 3.32 shows “power MOS FET main loss frequency dependence and relationship to main characteristics” in the case of use in a DC-DC converter.

Switching loss and drive loss increase at higher frequencies.

In order to make full use of component performance and reduce total loss, it is necessary to achieve a balance with on-resistance loss by appropriately setting and controlling the gate drive voltage in the high-frequency region.

In general, when a logic-level drive component is operated at operating frequency $f = 200$ to $300$ kHz or below, in order to minimize on-resistance, applying a gate drive voltage $V_{GS}$ of around $10$ V is effective from a total loss standpoint. Applying a higher voltage (for example, $V_{GS} = 15$ to $17$ V) is not really recommendable as drive loss only increases.

At high-frequency operation of $f = 500$ kHz or more, reducing total loss by optimization in a gate drive voltage $V_{GS}$ range of $5$ to $8$ V is effective in achieving higher efficiency.

![Figure 2.32 Power MOS FET Main Loss Frequency Dependence and Relationship to Main Characteristics](image)

2.8.2 Malfunction (Arm Shorting) Countermeasures in Motor Application

Figure 2.33 illustrates arm shorting in a small motor drive application, and applicable countermeasures, when P-channel and N-channel MOS FETs are used in combination.

This figure shows the upper P-channel MOS FET in the off state and the lower N-channel MOS FET in a chopping operating state.

In figure 2.33, the voltage waveform at point A is as shown in the figure, but as the lower N-channel MOS FET is now turned on and $V_{DD}$ changes to $0$ V, a charge current flows transiently via $Crss$ and $Ciss$ of the upper P-channel MOS FET, and a $\Delta V_{GS(0)} = \frac{|Crss|}{|Ciss+Crss|} \Delta V_{DSQ}$ Peak voltage is generated between the gate and source. When this $\Delta V_{GSQ}$ peak voltage exceeds $Vth$ of the P-channel MOS FET, the upper and lower components go to the on state simultaneously, an arm short-circuit current flows, and excessively large loss is caused.
In the case of use in an H bridge circuit, the other arm is also similarly susceptible to the occurrence of this phenomenon with an N-channel component.

The upper/lower component shorting phenomenon at the time of this transition is liable to occur under the following conditions.

1. More likely to occur the faster the switching operation (especially turn-on time) and the steeper dV/dt
2. More likely to occur the larger signal source resistance \( R_G \) (gate off-time constant)
3. More likely to occur the larger the Crss/Ciss values of the components used \( (K_S = \frac{\text{Crss}}{\text{Ciss} + \text{Crss}}) \cdot V_{DD} \) is a larger value than Vth of the component
4. More likely to occur the higher power supply voltage \( V_{DD} \)

Of items 1 to 4, item 4, power supply voltage \( V_{DD} \) is determined by the application and cannot be changed, so countermeasures are shown for remaining items 1 to 3.

1. Slow the turn-on time to suppress dV/dt (make gate resistance \( R_1 \) in the figure larger).
2. Make gate off-time signal source resistance \( R_G \) (MOS FET driver signal source resistance \( R_S \) and off-time external resistance constant \( R_g \)) smaller, and set low impedance between the gate and source.
3. Insert capacitance \( C_1 \) between the gate and source, make \( (K_S = \frac{\text{Crss}}{\text{Ciss} + \text{C1} + \text{Crss}}) \) \( V_{DD} \) smaller, and provide a margin.

Also, select an component with a small \( K_S \) and high Vth.

---

**Figure 2.33 Malfunction (Arm Shorting) Countermeasures In Motor Application**
2.8.3 Non-Isolated Synchronous Rectification Converter Low-Side Self-Turn-On Phenomenon

In appearance, this is similar to the above-described arm shorting phenomenon.

Figure 3.34 illustrates the low-side self-turn-on phenomenon in a non-isolated synchronous rectification circuit.

This phenomenon occurs at the switching timing at which high-side component Q1 is turned on while low-side component Q2 is off, and when the Q2 drain-source voltage changes abruptly from $V_{DS} \approx 0$ to $V_{DS} = V_{in}$, Ciss is charged via Crss of Q2, and Q2, which should really be off, is turned on.

That is to say, when $V_{GS}(Q2) = (Crss/Ciss + Crss) \times dV(t)$ (equation (1)) exceeds $V_{th}$ of Q2, self-turn-on occurs. As a result, Q1 and Q2 become on simultaneously, and excessive loss is generated, component heat radiation and a temperature rise are caused, leading to degradation of efficiency.

Regarding the low-side component characteristics, due to large-current operation, low $R_{DS(on)}$ design is necessary, and therefore there is a tendency for the capacitance relationship (Ciss, Crss) to be large. Regarding the high-side component characteristics, due to the design emphasizing high speed, high-speed switching characteristics are implemented, and $dV/dt$ becomes steeper. This suggests a tendency of susceptibility to the self-turn-on phenomenon.

Generally, the following two circuit countermeasures can be used.

1. Make only the high-side component turn-on time slower (suppress $dV/dt$).
2. Insert a capacitance C externally between the gate and source of the low-side component and (by making $(K_S = (Crss/Ciss + Crss)$ smaller) improve the self-turn-on margin.

As a future trend, it is necessary to make both Ciss and Crss smaller in component design for high-frequency operation (1 MHz or above) and also make improvements that take account of the ratio of Ciss and Crss (Crss<<Ciss). Also, it is necessary not only to implement component improvements, but also to make the impedance between the gate and source when Q2 is off ($R_S + j\omega L_S$) as small as possible from the circuit design and mounting standpoints (since the above $V_{GS}(Q2)$ expression essentially holds true when $(R_S + j\omega L_S) >> 1/j\omega Ciss$), and component performance can be fully exploited by means of these techniques.

![Figure 2.34 Problems in Synchronous Rectification Circuit](image-url)
3. Power MOS FET Applications

3.1 Application Map

Figure 3.1 shows a power MOS FET and IGBT application map.

![Figure 3.1 Power MOS FET and IGBT Applications](image-url)
3.2 Automotive Applications

3.2.1 Technological Trends in Automotive Electrical Equipment

Figure 3.2 illustrates technological trends in automotive electrical equipment.

![Figure 3.2 Technological Trends in Automotive Electrical Equipment](image)

3.2.2 Sample Automobile ABS Application

Figure 3.3 shows a sample automobile ABS application.

![Figure 3.3 Sample Automobile ABS Application](image)
3.2.3 Sample Automobile Power Steering Application

Figure 3.4 shows a sample automobile power steering application.

3.2.4 Sample Automobile HID Headlamp Control Application

Figure 3.5 shows a sample automobile HID headlamp control application.
3.3 Power Supply Applications

3.3.1 Switching Power Supplies

- Application equipment
  - Network servers, WS (workstations), RAID

Figure 3.6 shows a sample switching power supply application.

![Sample Switching Power Supply Application Diagram]

**Figure 3.6 Sample Switching Power Supply Application**
### 3.3.2 DC/DC Converters

- **Application equipment**
  - Notebook PCs, VCR cameras, on-board power supply secondary side, lithium-ion battery pack overcharging protection

Figure 3.7 shows a sample DC-DC converter application.

![Figure 3.7 Sample DC/DC Converter Application](image-url)
3.3.3 VRM (Voltage Regulator Module)

- Application equipment
  Desktop PCs, notebook PCs, network servers, WS (workstations)

Figure 3.8 shows a sample VRM application.
3.3.4 Base Station SMPS (Switch-Mode Power Supply)

Figure 3.9 shows a sample base station SMPS application.

Figure 3.9   Sample Base Station SMPS Application
### 3.3.5 Communication Equipment DC/DC Converter

Figure 3.10 shows a sample communication equipment DC/DC converter application.
3.4 Motor Drive Applications

3.4.1 Small Motor Drive

- Application equipment

<table>
<thead>
<tr>
<th>Application</th>
<th>Function</th>
</tr>
</thead>
<tbody>
<tr>
<td>H bridge</td>
<td>HDD (voice coil motor)</td>
</tr>
<tr>
<td></td>
<td>Camera motor, electronic throttle</td>
</tr>
<tr>
<td>3-phase</td>
<td>HDD (spindle motor)</td>
</tr>
<tr>
<td></td>
<td>PPC, printer (paper feed motor, polygon mirror)</td>
</tr>
</tbody>
</table>

Figure 3.11 shows sample small motor drive applications.